TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT								Docket No.						
			8327/ETCH/SILICON											
In re	: Ar	plication	on of:	Mui,	et al.									
		Serial I				ng Date	Examiner		Group Art Unit					
		10/690,				er 21, 2003								
Title:		METH	OM-EO	R CO	NTROLLIN	G ACCURACY	AND REPEATAB	BILITY OF	'AN ETCH PROCESS					
	1	O	C 1 7 201	B		Commission Alexandria, \	ess to: er for Patents /A 22313-1450							
1.	₫	applica entry o Action	ation other	er than onal sta nerits; or	a continued p ge as set forth	nt submitted here rosecution applica h in 37 CFR 1.491	with is being filed within tion under 37 CFR 1.5 in an international appl	53(d); within lication; befo	ths of the filing of a national three months of the date of re the mailing of a first Office est for continued examination					
	37 CFR 1.97(c)													
2. [The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), but prior to the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by the statement or fee as indicated below.												
						37 CFR	1.97(d)							
3. [3	The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(c), but on or before payment of the issue fee and is accompanied by the statement and fee as indicated below.												
			Re	quire	d Stateme	ents and/or F	ees Under 37 CF	R 1.97(c)	or (d)					
					h in 37 CFR 20-0782.	1.17(p). Please o	credit any overpayment	t or charge a	any insufficiencies to deposit					
						37 CFR	§1.704(d)							
4. [37 CFR §1.704(d) Each item of information in the accompanying Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application and this communication was not received by any individual designated in 37 CFP §1.56(c) more than thirty days prior to the filing of the Information Disclosure Statement.												
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		r, Patte neys at		Sher	idan, LLP			he Commissi	st class mail under 37 CFR §1.8 ioner for Patents, P.O. Box					
		•		enue,	Suite 100		R	0.11	h					
Shrewsbury, New Jersey 07702 Signature of Person Mailing Correspondence														
732	2-53	30-9404	4					Barbara J.						
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